EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1687	electrically conductive substrate same (Ti or Ni or Ta or Cu or Al or Nb or Fe or carbon or SS or carbon steel or brass or inconel or hastelloy or titanium or nickel or tantalum or copper or aluminum or niobium or iron or stainless steel)	US-PGPUB; USPAT	ADJ	ON	2007/09/26 07:42
L2 .	447	(diamond (coat\$3 or film or layer)) with (silicon (layer or substrate or wafer or support))	US-PGPUB; USPAT	ADJ	ON	2007/09/26 07:42
L3	2	1 and 2	US-PGPUB; USPAT	ADJ	ON .	2007/09/26 07:32
L4	7679628	@pd<"20031224"	US-PGPUB; USPAT	ADJ	ON	2007/09/26 07:42
L5	315	2 and 4	US-PGPUB; USPAT	ADJ	ON	2007/09/26 07:42
L6	4788	electrically conductive substrate	US-PGPUB; USPAT	ADJ	ON	2007/09/26 07:42
L7	. 5	5 and 6	US-PGPUB; USPAT	ADJ	ON	2007/09/26 07:53
L8	96	(epitax\$3 with diamond) same silicon (substrate or support or wafer)	US-PGPUB; USPAT	ADJ	ON	2007/09/26 07:55
L9	49	4 and 8	US-PGPUB; USPAT	ADJ .	ON	2007/09/26 07:55